

Review of ALERT 2016

Emanuel Karantzoulis

With contributions from: R. Bartolini, D. Einfeld, R. Nagaoka, A. Andersson, P. Tavares and R. Geometrante.Special thanks to Y. Papaphilippou and all participants for stimulating and interesting remarks during discussions.



The scope of the workshop was to bring together Research institutes – Industries

There were 67 registered participants from Asia, Europe and America including 15 from the industry

In total with locals about 75 people

N-2 talks (missing 2) on: https://indico.cern.ch/event/518497/timetable/

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Advanced Low Emittance Rings Technology (ALERT) 2016 Workshop

14-16 September 2016 Trieste, Italy Europe/Rome timezone



dvanced

Low Emittance Rings Technology



Trieste | 14-16 September 2016

A workshop on Advanced Low Emittance Rings Technology (ALERT 2016) is organized by ELETTRA on the 14th and 16th of September 2016, as a series of the Low Emittance Rings (LOWERING) Workshops, supported by the EUCARD2 project.

This will be the 2nd workshop on Low Emittance Rings technology after the one organized in the 2014 in Valencia.

The state of the art in the design of accelerator systems in light source storage rings has today many challenges and issues in common with those of linear collider damping rings and future e+/e- circular collider projects. A series of workshops were made since 2010 aiming at strengthening the collaborations within the low emittance rings' community, including the LOWERING collaboration network and the USR workshops community.

The goal of the ALERT2016 workshop is to bring together scientists but also industrial partners who are designing and building hardware for low emittance rings, with an emphasis on studies and experimental programs in existing rings and facilities. The impact of targeting and reaching ultra-low emittances to the design of technical systems will be addressed, including operational issues, manufacturing tolerances, calibration and stability/repeatability problems, in an environment dominated by synchrotron radiation.

With MAX IV in commissioning and ESRF II and Sirius in construction, this workshop will benefit from the technological solutions already tested at these labs and important lessons could be learned.

Workshop sessions will include:

- Insertion devices (including also superconducting devices)
- Magnets and alignment
- Injection systems (kickers, multipoles etc)
- RF systems, choices and design
- Vacuum systems and vacuum chambers
 Feedback systems
- Feedback system
 Instrumentation

Proposals for contributions to the workshop should be addressed to one of the Scientific Committee members

Rewiew of ALERT2016, Soleil, Paris

Emanuel Karantzoulis – 28 10 2016 2







Motive and Aims

Research centres cannot produce everything and should also help industries in R&D

The scope of the workshop was to focus and identify the areas of collaboration with industry trying to answer:

- At what/where sector are the needs / opportunities for R&D?
 - What / where are the capabilities for R&D?
 - Are there any and how can we fill the gaps?
 - How to improve the interaction / communication?
 - Initiate discussions





Institutes \rightarrow better accelerators (science and tech.) Industries \rightarrow financial return

Low Emittance Rings ~2018-2028 (beyond MAX IV – ESRF-EBS – SIRIUS)

APS-U, ALS-U, ELETTRA 2.0, SLS II, PETRA IV, HEPS, DLS II, SOLEIL, ANKA, ... (Iran, Mexico, Thailand, African LS, ...) CepC, FCCee

100-200 Meuros (acc only) each $\rightarrow \sim 1 B \in$ 200-500 Meuros (inc. beamlines) each $\rightarrow \sim 2 B \in$



Magnets (static and pulsed)

IDs

Vacuum

RF

Mechanical engineering

Diagnostics, Electronics (e.g. BPMs, feedbacks)



Going boldly to the limits (or not?)

General Session

Highlights from MAX IV commissioning and operation, Pedro Tavares (MAX IV)

ESRF II, Dieter Einfeld (ESRF)

Sirius and Sirius magnets ,James Citadini (LNLS)

BESSY-VSR-Project , Martin Ruprecht (BESSY)

Sirius Budget (2016) Accelerators 94 M € 13 beamlines 133 M € 200 M € Building Human Res 53 M € Total 480 M € (Not all money given) 3 years to produce 200 magnets 1 year to produce 800 magnets Full NEG-ed chamber Coating system in the facility Partnership LNLS/WEG for magnets NdFeB with 15 µm parallel surface for Superbends Booster dipole (with quadrupole and sextupole components)

ESRF, High gradient quads y [mm] 91 T/m gradient, 388 – 484 mm 3 length 2 12.7 mm bore radius, 11 mm 1 vertical gap, $+/-20 \mu m$ pole accuracy -15 -10 -5 Also DLG and DQ1: 1.028 m, 0.57 T, 37.1 T/m Schedule margin 2-3 months Compact designs: are *compact* components key to achieving (Nb cavities) low emittance in recent designs - can the trend going to continue even further?

All below 0.3 nm rad



MAX IV inj. efficiency > 80% V DA as predicted, H DA should also be measured

BESY-VSR double 3HC to create short and long bunches RF voltage at 1.5 GHz 20 MV RF voltage at1.75 GHz 17 MV (Nb cavities) Effective bunch length (rms) 1.7 ps



Insertion devices

Super-conducting Undulators at ANL, Joel Fuerst (ANL)

Planar superconducting undulator with neutral pole:

test results of the prototype, Nikolay Mezentsev (BINP)

Fixed gap undulators and performance, Bruno Diviacco (Elettra)

Use of materials of superconductivity (NbTi/Cu, NbSn/Cu) has considerable advantage against permanent magnets



Long-term (3 -4 year) ANL goal is to develop a vendor for "turn-key" SCU production Several subsystems on existing SCUs (1.67 T) were fabricated in industry from ANL designs:

- -Vacuum vessel
- -Thermal shields
- -Liquid helium reservoir
- -Magnet cores

Cryostat evolution: better thermal performance, improved alignment, smaller, cheaper, possible LHe-free

cooling ..

Parameter	Symbol	Design	Measured	Units
Nominal on-axis, peak field (at 80% short-sample limit)	B ₀	1.67	1.6657	т
Nominal peak undulator parameter (at 80% short- sample limit)	K ₀	3.26	3.260	-
Nominal excitation current (at 80% short-sample limit)	I _o	~600	588	А

Design features of superconducting windings and assembly of the magnet allow to hope for significant increase in accuracy of manufacture and decrease of cost of a magnet.

The quantity of windings is twice decreased. It is easy to provide mass production, high quality of pole fabrication, control of key dimensions and quality for every pole



APU has many advantages



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Insertion devices (from Magnets & alignment session)

NbTi wiggler tests at ANKA ,Axel Bernhard (ANKA)

CPMUs vs SCUs vs In-Vacs vs APD EPUs DELTA

 $NbTi - NB_3Sn$

Field (phase errors) Shimming and correction techniques Radiation hardness Cost

New SC devices without He bath

CLICDW Design: Conduction cooling

The Nb-Ti CLIC damping wiggler prototype with conduction cooling modular design has passed Factory and Site Acceptance Tests and is installed in the ANKA storage ring cryogenic system: performance outstanding

KIT-CERN-BINP collaboration





Magnets

MAX IV 3 GeV ring magnet, Martin Johansson (MAX IV) Magnets for DDBA and lessons learned for Diamond-II, Abolfazl Shahveh (Diamond)

Magnets for Elettra 2.0, Davide Castronovo (Elettra)



25mm aperture.

Have the magnet suppliers do as much as possible, for example all field measurements.

The "magnet blocks" are an alignment concept that relies on the accuracy of CNC milling and 3D coordinate measurement machines, techniques which are available at large number of machining subcontractors.

•

As opposed to stretched wire alignment, which is typically only available at a few accelerator labs.

With only a limited amount of prototyping done by MAX-lab before purchasing the production series, the "R&D" of finding out what mechanical tolerances were actually achievable for these magnet blocks was essentially done by our suppliers.



Gradient Dipole: B=0.8 T and G=14.4T/m The good field region is X: \pm 10 mm Y: \pm 4mm Quadrupoles designed to reach max G=70 T/m Bore radius 15 mm Attempt to reach 20um pole accuracy with precision milling proved challenging Dipoles: Aligned mechanically using a laser tracker target +/-50 um Multipoles: Aligned magnetically using stretch wire bench on complete girder target +/- 25 um



Bore radius 26 mm B=0.8 T G < 15 T/m GQ < 50 T/m With Lp=Lm All air-cooled





Magnets & alignment

Dipoles with longitudinally variable field for CLIC damping rings ,Manuel Dominguez (CIEMAT)

NbTi wiggler tests at ANKA ,Axel Bernhard (ANKA)

Vibrating wire method and hall probe measurements for combined function magnets (DQ) alignment, Alexander Temnykh (Cornell)

Permanent magnets are the best choice to provide a fixed field: no power consumption and very compact. (1-1.7 T, 11 T/m and LG) Taking into account:

Temperature variation in the tunnel will be as low as $\pm 0,1^{\circ}C$

Sm-Co radiation tolerance is higher than Ne-Fe-B

Low radiation expected, but higher in the low field sections (magnet ends)

The permanent magnet volume and weight reduction using Ne instead of Sm goes up to 45%.

The cost of Neodymium magnets is lower than SmCo. pointing towards the use of:

Ne-Fe-B magnets in the high field region

Sm-Co magnets in the low field regio

NO specific temperature compensation Interaction with CERN





The technique is based on the excitation of the harmonics of a wire vibration by Lorenz forces between current in a wire and the surrounding magnetic field.

It was used on many occasions : Cornell, BNL, SLAC, etc

Precision of magnetic axis localization in respect to wire ~1micrometer or better

Using Vibrating Wire and Hall probe magnetic field measurement techniques, quadrupole and combined function magnets (DQ) can be magnetically surveyed and placed in required **position in respect to girder fiducials with precision better than 20 microns.**



Magnets and magnets&alignment

High gradient and small bore apertures (how high and how small can we go?) Review tolerance requirements – how good do magnets really need to be ?

Complex dipoles (DQ, DL) Permanent magnets for achieving very large gradients ? Cost-effective series production of permanent magnets

Precision machining (poles, mating surfaces, ...)

Measurements (stretched wire with small bores) Alignment (in situ)



Beam transfer systems

Production of round beams, Peter Kuske (HZB - BESSY)

Development of Multipole Injection Kicker for SOLEIL and MAX IV, Pierre Lebasque (Soleil)

Stripline kicker development at ALS , Cristoph Steier (LBL)

Transient studies of the stripline kicker for beam extraction from the CLIC damping rings ,Carolina Belver Aguilar (CERN)

Inductive adders ultra-stable kicker pulse generation, Janne Holma (CERN)



Round beams using skew quad by exciting coupling resonance at 100 kHz 4 methods presented Other methods like using solenoids?

More investigation needed to consolidate

Technical Approach	Injection	Emittance control	Complexity
Radial Damping Wigglers	off-axis	yes	large
Möbius Accelerator	on-axis	no	moderate
Resonance Excitation	off-axis	(no)	moderate
On Coupling Resonance	off-axis, tune shift with ampl.	(no)	trivial



Very challenging , high accuracy required (e.g. 10um in wire position) In delay due to some external company



ALS On-axis swap-out injection Building 6 mm gap stripline kicker for test in ALS (<10 ns rise/fall time) using inductive adders

CLIC also studies stripline extraction kickers using inductive adders with rise time 100 ns and very flat-top of $1\mu s$ (stable deflection angle)

Inductive Adders for CLIC

±0.02 % (± 2.5 V) requirement for the flat-top stability of ±12.5 kV, 160 to ~900 ns pulse is an extremely demanding specification! However the pulse power modulators for CLIC DR kicker systems are very probably feasible with inductive adder technology.

Pulsed magnets (injection in small apertures) Kickers for swap out rise time (1-few ns)

flattop (10-4)

Kicker for top-up

4 equal pulses

Non-linear kickers -> difficulties with tolerances

CW skew quadrupole





RF technology related contributions

- MAX IV RF Systems --- Lars Malmgren (MAX IV)
- Conceptual Design of a 2 GHz RF System for the CLIC DRs --- Alexej Grudiev (CERN)
- State-of-the-art RF solid state amplifiers ---- Massamba Diop (SOLEIL)
- Experience and future trends of Harmonic RF systems --- John Byrd (LBNL)

100 MHz with Rohde & Schwarz 60 kW CW solid state liquid cooled amplifiers based on two 30 kW transmitters / amplifiers with additional power combiner



CLIC 1 GHz 2 GHz, no train interleaving after DR Classical RF system based Baseline Alternative 2.0 on the NC ARES-type $P_{RF} = 3.8 \text{ MW}; \text{ L} = 32 \text{ m};$ $P_{RF} = 5.9 \text{ MW}; L = 48 \text{ m};$ cavities Cavity design: OK Cavity design: ok? Classical RF system based Alternative 1.1 Alternative 2.1 on the SCC cavities $P_{RF} = 0.6 \text{ MW}; L = 108$ $P_{RF} = 0.6 \text{ MW}; L = 800 \text{ m};$ Cavity design: NOT OK m: Cavity design: ok? RF system with RF Alternative 1.2 Alternative 2.2 $P_{RF} = 1.3 \text{ MW}; \text{ L} = 16 \text{ m};$ $P_{RF} = 2.1 \text{ MW}; L = 24 \text{ m};$ frequency mismatch Cavity design: OK Cavity design: OK "A-la-linac" RF system with Alternative 1.3 Alternative 2.3 $P_{RF} = 3.3 \text{ MW}; L = 8 \text{ m};$ $P_{RF} = 5.8 \text{ MW}; \text{ L} = 12 \text{ m};$ strong input power modulations Cavity design: OK Cavity design: OK



High efficiency (65%), redundancy, modularity, low phase noise, MTBF > 1y Elettra Sincrotrone Triacta

Larger machines may benefit from lower rf. freq.

higher rf. Frequency -> Reducing size longitudinally

instead smaller machine may benefit from

How to fight IBS and improve lifetime? HCs

cryomodule design – HOM reduction

Technical challenges and R&D needed

	Active	Passive	NC or SC RF?			
NCRF	 Requires input coupler Requires RF source and controller Can reach optimum BL at any current Multiple cavities 	 Lower cost Only "optimum" bunch lengthening at most at a single high current (maybe nowhere) Higher total R/Q for transients Multiple cavities 				
SCRF	 Requires SC infrastructure Requires input coupler Requires RF source and controller Can reach optimum BL at any current Lower R/Q for transients One or two cells 	 Requires SC infrastructure Never reaches optimum BL (always 90 deg phase) Lower R/Q for transients One or two cells 	High RF fr Low RF fr rces: Low Frequency (50-20 technology option range. SSPA favo			
SS am n e	High Frequency (>1.5 10 kW range in S power sources m ities: High frequency cavition NC have large po					
Choice of frequency 100 MHz – 500 MHz – higher (e.g. 2 GHz) Larger cavities (100 MHz) might have long conditioning times						

High RF frequencies, Low RF frequencies

w Frequency (50-200 MHz) offers several technology options at the right power range. SSPA favored. gh Frequency (>1.5 GHz) available at the 10 kW range in SSPA format. Higher power sources more rare.

gh frequency cavities (>1.5 GHz) exist. NC have large power densities and are limited to ~10 kW/cell. HOM-damped SC cavities exist but typically limited by input power coupler. Is the small beam pipes of 4GLS hinting towards higher frequency cavities? Most HOM-damped designs exist in the

350-500 MHz range. HOM-damping for low frequency cavities can still be optimized. How much HOM damping is needed with Landau cavities in use?

Almost all of the machine diagnostic/auxiliary systems

depend on choice of RF frequency. The practical optimum

frequency depends on many factors.

Special harmonic cavities e.g. VSR concept



Some points learned from the presentations and raised during the discussions (notes from R. Nagaoka):

- High gradient RF voltage using the superconducting multi-cell cavities à la BESSY-VSR may be a good effective means to provide much higher intensity short photon pulses with a high repetition rate in storage rings. →
 Compatibility with low emittance/Suppression of HOMs must be further pursued.
- SSPAs (Solid State Power Amplifiers) are becoming explosively the new RF power source in modern accelerators after the pioneering and successful development and experiences made at SOLEIL. Their effective operating range in frequency is rapidly increasing. There was also a counter argument that Klystron lifetime is also not said to be comparatively short. However, there is a clear trend that the number of Klystron manufacturers is decreasing.
- Lowering the main RF frequency f_{RF} cannot always be a solution in fighting against IBS and reduced Touschek lifetime, as reduces the number of buckets and so increases the bunch current.
 - Machine specificity such as the machine energy, circumference and foreseen filling modes must be taken into account in evaluating the pros and cons.
 - Large machines having the margin to sacrifice the number of buckets may profit by decreasing f_{RF} .
 - Higher f_{RF} may enhance beam-induced heating due to widened bunch spectra
 - Generally, there are constraints due to components dependence on f_{RF}
- Active lengthening of a bunch using harmonic cavities may be a common effective means of combatting the IBS, reduced Touschek lifetime and even fighting against collective instabilities for future ultra low-emittance rings not intending to produce short bunches. The choice of superconducting versus normal conducting requires careful machine-dependent comparisons



Feedback systems and Enginneering

Fast orbit Feedback for ESRF-EBS, Benoit Roche (ESRF)

Application of wide-band feedback systems for low emittance rings , John Fox (SLAC)

Engineering for DDBA and lessons learned for Diamond-II, Nigel Hammond (Diamond)

Risk assessment for the ESRF II, Dieter Einfeld (ESRF)

For the ESRF-EBS, beam stability requirements are comparable with ESRF (roughly same vertical beam size, below micron) Requires 320 bpm and 288 (96 fast) correctors having fast and slow FB. 10 kHz acquisition no big changes

Wideband Intra-Bunch Feedback





Feedback systems and Enginneering

Engineering for DDBA and lessons learned for Diamond-II, Nigel Hammond (Diamond) Risk assessment for the ESRF II, Dieter Einfeld (ESRF)



Manufacturing Errors and Overlaying Bake out Cabling. Additional spacer required to separate cable route from water cooling tube route etc...

- Physically separate magnet alignment, vessel construction and cabling areas. Or build in flexibility to change a single area from temperature controlled to clean and then general.
- Appoint a Girder Assembly Supervisor devoting 100% of his/her time to setting priorities, resolving conflicts and maintain tidiness of area during the girder assembly.
- Employ full time 'Expeditor staff', or a 'Third Party Inspection Agency' to monitor progress and quality control at major suppliers premises.
- Include cable routes in the CAD model, especially routing approaching cable terminations. Don't forget the vessel bake-out cabling.
- Carry out design development for flange alignment and seal design for RF continuity.
- Carry out trials of metal joining processes in conjunction with component design.

Mechanical engineering MAX IV blocks concept Precision girder machining (20 um over 3-5 m) T-slot keyways vs dowels

> Girder motion movers by-hand

high precision movement in monochromators narrow band-pass filter



Risk Analysis

WP-02 . Magnets			Risk			
Risks	Type of ris▼	TITLE	Impact on/ Phase	Action Plan / Mitigation / Remarks	Likel.	Imp.
1	Delays	Production of prototypes and series magnets.	Master planning/ Production	Following up the contracts	2	3
2	Delays	Accuracy of position shims.	Production of the series magnets	Any problems concerning the shims will be solved during the pre-series production.	2	1
3	Delays	Tolerances of the quadrupoles and sextupoles.	Planning/ Production	Problems will be solved during production.	1	1
4	Delays	ESRF measurement benches.	Delivery schedule/ Production	Implement redundancy on some spare components of the benches (e.g. a spare motion controller will be installed)	2	1

WP-10: \	/acuum Systen	RISKS				
Risks 🔽	Type of risk	TITLE	Impact on/ Phase	Action Plan / Mitigation	Likel.	Imp.
1	Delay	Vacuum chambers complexity: follow the manufacturuing technical solutions.	Planning / Assembly	Close contact with companies for the pre-series construction phase	2	2
2	Technical	Baking system: Unforeseen difficulties in integrating it.	Design & Plann. / Ass. & Install.	Validate the compatibility of the coaxial sheathed heaters.	1	2
3	Delay	Underestimation of the initial outgassing of the vacuum chambers with the first beam	Planning / Commiss.	Test prototype chamber with beam. Dedicate more time to conditioning.	2	2



The highest risks are "delays" with 28 tasks and "technical" with 11 tasks.

But sometimes delays are due to "technical"



Diagnostics, Instrumentation and coating

Ultra-low vertical emittance measurements in the Australian Light Source , Mark Boland (Australian Synchrotron)

Conceptual design of X-ray interferometer for extremely apparent small beam size in FCC-ee and beam halo measurement with coronagraph for HL LHC , Toshiyuki Mitsuhash (KEK)

Ultra-short bunch length diagnostics , Axel Bernhard (KIT-ANKA)

Laser engineered surfaces , Amin Abdolvand (Dundee University)

Experience with coating of low gap chambers , Roberto Kersevan (CERN)

Vaccuum and other Key technologies and engineering

MAX IV 3 GeV ring vacuum system ,Marek Grabski (MAX IV)
Vacuum systems for DDBA and lessons learned for Diamond-II, Matthew Cox (Diamond)
>> Experience and future trends of Harmonic RF systems , John Byrd (LBL)
Transverse and horizontal beam size diagnostics with visible SR , Åke Andersson (MAX IV)
Particle Accelerator Components' Metrology and Alignment to the Nanometre scale (PACMAN) , Michele Modena (CERN)



Good method and lattice model to reduce the coupling and hence the vertical emittance { need to improve ultra low emittance measurements.

Good success with measuring ultra low vertical emittances using undulator spectra and interferometry (from a 140 m long beam line)



Halo observation by using the coronagraph in HL LHC and single and double slit interferometry



method	wavele ngth	measurable minimum beme size in angular diameter in µrad	Correspondi ng size in 100m in µm	Correspondi ng size in 1000m in µm
Visible light imaging	500nm	50	500	5000
X-ray pinhole	0.1nm	0.5	50	500
FZP imaging Of soft X-ray	0.35nm	0.3	30	300
Visible light interferometry	400nm	0.47	47 (resolution 5)	470
Visible light Interferometry with imbalance input	400nm	0.2 (scaled) No measurement	20	200
Coded aperture	0.3nm	0.5 0.1 (estimation) No measurement	50 10	500 100
X-ray Interferometry (new method)	0.1nm	0.01	1	10µm





Emitt. Meas via beam size using diffractometer Measuring up to 2-3 um beam sizes



Investigation of the Micro-bunching instability in Short-Bunch Operation Fast acquisition 900 kHz (1imag/um) Using THz and EO methods spectral decoding long. Phase space detail: development of sub structures

Diagnostics-Electronics stability (> 100Hz) integration with beam-lines Measurement of small size beams (still valid the 10% rule?) also from dipole, or V undulators BPMs high accuracy in different conditions, e.g. t-b-t, single bunch, low current (rf bpms?) Feedback systems LMFB, TMBF intra-bunch train THz detectors and electro-optical crystals are used to a large extent for short pulse resolution ->Industry cooperation?



Vaccuum, coating and other Key technologies and engineering

Laser engineered surfaces , Amin Abdolvand (Dundee University) Experience with coating of low gap chambers , Roberto Kersevan (CERN) MAX IV 3 GeV ring vacuum system ,Marek Grabski (MAX IV) Vacuum systems for DDBA and lessons learned for Diamond-II, Matthew Cox (Diamond) Particle Accelerator Components' Metrology and Alignment to the Nanometre scale (PACMAN) , Michele Modena (CERN)

Laser engineered surfaces.

A number of accelerator physics problems can be alleviated by treatment of the vacuum surfaces, like secondary electron yields, secondary photon yields that can be substantially decreased. Emissivity of in-vacuum materials can be increased etc.



- 1. In the new machines the whole vacuum system has become a "low-gap chamber", not only the IDs. Some novel ideas have surfaced which ask for extremely small diameter chambers, less than 10 mm ID, and for this kind of designs there is no alternative to NEG-coating: the specific conductance of a 10 mm circular profile is about 0.9 I·m/s for CO.
- 2. For out-of-vacuum IDs, there is no alternative to NEG-coating, other than using some "expensive" design like the chamberantechamber solution used at APS, where "expensive" means needing a lot of ancillary longitudinal space for installing a lumped absorber and tapers, reducing the space available to IDs.
- 3. The Vacuum Surfaces and Coating group of CERN has been heavily involved in the fabrication of MAX-IV vacuum chamber, namely "the most difficult ones", i.e. those for which industry was not ready to bid and get a contract, too risky



NEG coated OFS Copper (almost all) (6 km of vacuum pipe coated)



	2E-09
١,	1E-09 @dose=16 Ah
	1E-09
Ŀ	9E-10
mba	7E-10
P _{av} [5E-10 @dose=95 Ah
	3E-10
	1E-10
	2 2 2 100 100 1100 1100 1100 1100 1100
	I [mA]

Cost reduction for series production Novel materials, manufactoring and joining tecniques Replace entire vacuum system (basically 18 x 27 mm ellipse internal) for one cell (17.35m) (copper OFS alloy and 316 LN (stainless steel) Installation + beam conditioning in a working machine with \leq 8 weeks downtime.

	NEG coating	No NEG coating
	Better ultimate vacuum Only active gases pumped (in the absence of SR) so may required auxiliary pumping anyway.	Worse ultimate vacuum between pumps – should be good enough though All gases can be pumped
	Quicker beam conditioning (few A.h)	Slower beam conditioning (100s A.h)
	Always need to bake / reactivate after venting (probably)	Don't always need to rebake after venting
	Significant R & D and setup time and effort needed for variety of vessel geometries	Much less R & D, time and effort needed
	Sensitive to saturation, surface poisoning, flaking etc	No coating to flake off or get poisoned Larger pumping capacity.
_	Probably more expensive overall (at commercial coating prices). Economics may be different for a whole machine	Probably cheaper overall despite additional discrete pumps, controls, wiring etc
4		

Smaller apertures, chamber heating from radiation NEG coating of vacuum chambers of smaller and smaller transverse dimensions. NEG or no NEG? -> evidence of fluorescence , old evidence of inductive impedance increase with NEG. Small chambers with Complex geometries Polishing of internal surface (low SEY) Laser ablation Coating (conducting, e.g. kickers for top-up)



PACMAN = a study on Particle Accelerator Components' Metrology and Alignment to the Nanometre scale, is an Innovative Doctoral Program network founded by the European Commission FP7 Marie Curie Actions, hosted by CERN, providing training to 10 Early Stage Researchers (ESR) all enrolled to PhD studentship programs.

CLIC Mechanical prealignment: ~ 0.2-0.3 mm over 200 m Active pre-alignment: 14-17 µm over 200 m

Industry presentations

Collaboration with industry

SAES group activity in accelerator technology ,Paolo Manini (SAES Getters SpA)

Strumenti scientifici CINEL: a reliable supplier for products as well as a skillful partner for R&D projects, Riccardo Signorato (CINEL)

SiC MOSFET & Diode Roadmap, Wolfgang Knitterscheidt (eurocomp)

Superconducting undulators ,Cristian Boffo (Babcock Noell GmbH)

KYMA: a success story of technology transfer and strategic partnerships ,Geometrante Raffaella (KYMA)

Tunga Lyft - Installations at MAXIV, Olle Torsteni (Tunga Lyft)



Remarks during discussion

Summary and close out

Summary talk by R. Bartolini

Discussion and close-out

Notes by R. Geometrante

List of facilities and their budget/cost estimates (Europe/USA/Cina...) - see 1st slide

Kickers for top-up Industry to go back to Klystron?

Power supply and energy saving

Control system and operating software system / integration Timing and big data coming from beam-lines

Vibrations, temperature control, ionized water

Kicker development for injection to be supported by EU support like PACMAN for alignment

Procurement rules To choose the most appropriate procedure according to the kind of products

Quality control / visit to the customer

Feedbacks to companies when they are not awarded the contract - lessons learnt useful information for the supplier

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Different interaction depending on institutes

- (plain) customer-manufacturer
- (collaborative) R&D collaboration
- (active) knowledge transfer (\rightarrow spin off)
- (political) engaging with local industries

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(plain) customer-manufacturer

Steps

Specifications call for tenders out – bids in – contract placed design reviews – production – FATs delivery -> mostly in delay Assume specs are written clearly responsibility assigned critical quantities to be met identified Assume manufacturer can deliver no major technology unknown



customer-manufacturer – issues and improvements

communications

common design reviews

monthly report (is there anything better?)

delays

expeditors

Complaints from institutes? P. Lebasque's talk, Dieter's talk, (delays..)

Complaints from industries:

- Procurement rules need revision (should not win always the cheapest)
- \checkmark To choose the most appropriate procedure according to the kind of products
- ✓ Quality control / visit to the customer
- ✓ Feedbacks to companies when they are not awarded the contract lessons learnt useful information for the supplier

Comments

Industry has knowledge and capabilities and customer buys it

Industry is protective of their know-how



(collaborative) R&D collaboration

- Technology areas missing on both parties
- There is the need on both side to work together to develop the technology
- Institute is willing to engage with industries at design/prototypes level and R&D from early stages
- Both increase their knowledge however attention with intellectual property

There are advantages on both sides

Institute benefits Sell knowledge through licensing Can avoid time consuming call for tenders Can push costs down

Industry benefits Can offer high tech product Reduce R&D cost Better delivery (on time and on budget) Sell products to more institutes and customers Open up markets worldwide Sell knowledge through licensing



Active knowledge transfer (KT)

Institute developed knowledge-technology during many years; potential markets exist and the institute is interested in commercialisation (not all of them are)

But no industry is capable or does not exist (globally, locally)

However for various reasons (also political) there is the need to transfer to industry

Financial benefit for the institute

licence a technology

give IPR (intellectual property rights) right to manufacture (right might not be exclusive can be transferred to many industries) competition → reduce cost Spin off companies: direct knowledge flow from institute to company that can be extend it to other applications (e.g. CERN incubation centres, Kyma-Elettra, ...) or direct(?) financial support (unlikely)

How does KT work? KT is different in different labs, do prototyping together? what can be industrialised? how to engage with industry? Make them aware of KT?

Different personal approaches; giving away knowledge or not? Which institute want to transfer what?

Institute view? Industry view?



engaging with local industries (mostly political)

strengthen/foster national industry with knowledge transfer (e.g. Brazil WEG, Iran MAPNA) France spin out (ESRF area) CERN?

But large projects cannot do everything nationally



Some remarks and advise

According to D. Einfeld

- In general the relationship between the industry and the laboratories is pretty good. The industry wants that you are satisfied with the final product.
- The industry is capable to build all the accelerator components.
- The industry is capable to build systems (injectors) for an accelerator complex.
- For medical applications the industry can build turn key synchrotrons.
- Have also in mind that the industry has to earn some money. They have to pay the salaries for their employees and they have to survive.
- The companies want to have the contract and therefore they promise you a lot of things, sometimes too much. Therefore:
 - Write the "Technical Specifications" for the CFT very careful because it as an appendix a part of the contract. Do not write anything that you do not understand. Take care for the tolerances, use only tolerances which are achievable by the industry.
 - The companies do not provide all the required answer to your specs, there is a need to clarify everything in the negotiation about technical issues. Any unclear point has to be clarified before signing the contract.
- Following up the production of the prototype and the series very carefully.
- Take care of the time schedule, (life is sometimes very complicated).



Final considerations

First meeting to foster discussion and reflect on how to improve the collaboration between research facilities and industries

Consider:

technical challenges and required R&D what industries are interested what capabilities where technology transfer can happen

How to foster this exchange?

special committees/individuals

(e.g. industry liaison officers)-> in some labs already exist (Electra, ESRF,..)

Actions:

workshops/networks – invite industries

seconded PhD with EU support (Marie Curie netw.)

Use the PACMAN example for univ + lab + company collaboration



Thank you for your attention

